



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Wang, et al.

Serial No.: 10/800,112

Filed:

March 12, 2004

Confirmation No.: 8920

For:

Method of Depositing an

Amorphous Carbon Film for

Metal Etch Hardmask

**Application** 

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Group Art Unit: 1763

Examiner:

Unknown

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

CERTIFICATE OF MAILING

37 CFR 1.8

I hereby certify that this correspondence is being deposited on <u>March 23, 2005</u>, with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.

March 23, 2005

Date

Signature

## PRELIMINARY AMENDMENT

Prior to examination, please amend the above-identified application as follows. Although Applicants believe that no additional fees are due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/AMAT/8245/BKH, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

Amendments to the Specification begin on page 2 of this paper. The Pending Claims are reflected in the listing of claims which begins on page 3 of this paper. Remarks begin on page 7 of this paper.